

APR 10 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Haupt	Docket No.:	INTECH 3.0-104
			(2003 P 51718 US)
Filed:	1/28/2004	Examiner:	Thanh Y. Tran
Serial No.:	10/766,053	Art Unit:	2822
Title:	Method for N+ Doping of Amorphous Silicon and Polysilicon Electrodes in Deep Trenches		

Mail Stop Amendment
 Commissioner for Patents
 P. O. Box 1450
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Respectfully submitted,

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PTO/SB/08a (08-03)

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<p>Substitute for form 1449A/PTO</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p><i>(Use as many sheets as necessary)</i></p>				Complete if Known	
Sheet	1	of	1	Application Number	10/786,053
				Filing Date	1/28/2004
				First Named Inventor	Haupt
				Art Unit	2822
				Examiner Name	Thanh Y. Tran
				Attorney Docket Number	INTECH 3.0-104 (2003 P 51718 US)

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Signature		Date Considered	
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